

2811

In re Application No. 09/982,845

Docket No. 03500.015894.

TAKAHARU KONDO, ET AL.

Application No.: 09/982,845

Examiner: S. A. Gebremariam

Filed: October 22, 2001

Group Art Unit: 2811

For: SILICON BASED FILM
AND PHOTOVOLTAIC
ELEMENT

Date: October 28, 2002 (Monday)

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

RECEIVED
NOV - 5 2002
TECHNOLOGY CENTER 2800

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20	MINUS	20	= 0	x \$9 \$18	.00
INDEP. CLAIMS	1	MINUS	3	= 0	x \$42 \$84	.00
Fee for Multiple Dependent claims \$140°/\$280						Prev. paid
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$_____ is enclosed.

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner
of Patents and Trademarks, Washington, D.C. 20231
on Oct. 28, 2002

(Date of Deposit)

Damond E. Vagnais, Reg no. 52,310

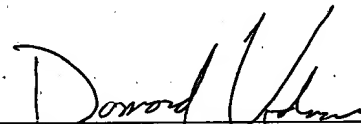
Name of Attorney for Applicant

Damond E. Vagnais
Signature

Oct. 28, 2002
Date of Signature

- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

CA_MAIN 52615 v 1



03500.015894.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

TAKAHARU KONDO, ET AL.)

Application No.: 09/982,845)

Filed: October 22, 2001)

For: SILICON-BASED FILM
AND PHOTOVOLTAIC
ELEMENT)

Examiner: S. A. Gebremariam

Group Art Unit: 2811

October 28, 2002 (Monday)

9/a

FJONES

11-8-02

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action dated July 26, 2002 (Paper No. 6), please
amend the application as follows:

IN THE CLAIMS:

Please amend Claim 1 as follows. A marked-up copy of amended Claim 1,
showing the changes made thereto, is attached. Note that all claims currently pending in

RECEIVED
NOV - 5 2002
TECHNOLOGY CENTER 2800

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner
of Patents and Trademarks, Washington, D.C. 20231
on Oct 28, 2002

(Date of Deposit)

Damond E. Vachals, Reg. no. 52,310

Name of Attorney for Applicant

Damond Vachals
Signature

Oct 28, 2002
Date of Signature